



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re ~~Patent~~ application of

Shunpei YAMAZAKI et al.

Serial No. 09/535,015

Filed: March 24, 2000

For: METHOD OF MANUFACTURING  
A SEMICONDUCTOR DEVICE

)

) Group Art Unit: 2811

) Examiner: S. Crane

)

**CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with  
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**INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents  
Washington, DC 20231

**BEST AVAILABLE COPY**

Sir:

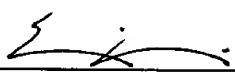
In accordance with the duty of disclosure as set forth in 37 C.F.R. §1.56, Applicants  
hereby submit the following information in conformance with 37 C.F.R. §§ 1.97 and 1.98.  
Pursuant to 37 C.F.R. § 1.98, a copy of each of the documents cited is enclosed.

The documents are being submitted within before the first Office Action on the  
merits, therefore no fee or certification is required under 37 C.F.R. § 1.97(b).

It is requested that the accompanying information disclosure statement be  
considered and made of record in the above-captioned application. To assist the Examiner,  
the documents are listed on the attached form PTO-1449. It is respectfully requested that  
an Examiner initialed copy of this form be returned to the undersigned.

The Commissioner is hereby authorized to charge any fees connected with this filing  
which may be required now, or credit any overpayment to Deposit Account No. 50-2280.

Respectfully submitted,

  
Eric J. Robinson  
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